

EL978317256US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In application of: De La Cruz et al. Serial No: Filed: Confirmation No.: Title: REMOTE ENTERPRISE MANAGEMENT OF HIGH AVAILABILITY SYSTEMS	: Group Art Unit: : Intellectual Property Law Department : International Business Machines Corp. : 11400 Burnet Road : Austin, Texas 78758
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DATE: 01-20-04

INFORMATION DISCLOSURE STATEMENT

Mail Stop Patent Applications

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Applicants submit herewith patents, publications or other information of which they are aware, which they believe may be material to the patentability of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR 1.56.

While this Information Disclosure Statement may be "material" pursuant to 37 CFR 1.56, it is not intended to constitute an admission that any patent, publication or other information referred to herein is "prior art" for this invention unless specifically designated as such.

In accordance with 37 CFR 1.97(g) the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56 (a) exists.

The attached form, PTO-1449, provides a listing of patents, publications, or other information as required by 37 CFR 1.98 (a)(1).

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Amy Pattillo", with a long horizontal flourish extending to the right.

Amy J. Pattillo
Attorney for Applicants
Registration No. 46,983
(512) 402-9820

In Place of FORM PTO-1449 (Modified)

LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION DISCLOSURE
STATEMENT

Serial No. _____

Applicant: De La Cruz et al.

Filing Date: _____

Group: _____

Atty. Docket No. AUS920040029US1

Reference Designation

U. S. PATENT DOCUMENTS

Examiner <u>Initial</u>	Document <u>Number</u>	<u>Date</u>	<u>Name</u>	<u>Class</u>	Sub- <u>class</u>	Filing Date <u>if</u> <u>Appropriate</u>
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FOREIGN PATENT DOCUMENTS

Examiner <u>Initial</u>	Document <u>Number</u>	<u>Date</u>	<u>Country</u>	<u>Class</u>	<u>Subclass</u>	<u>Translation</u>
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner
Initial

_____ CA	Joedecke et al., Highly Available DB2 Universal Database using Tivoli System Automation for Linux, ftp://software.ibm.com/software/data/pubs/paper/halinux.pdf , Available as of 1/14/2004, Copyright 2003
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